

Workshop on Machine Learning and Music, Vilnius, Lithuania (2024)

Can Patch Selection Heuristics Enhance Layout Analysis of Music Scores?

Francisco J. Castellanos
Juan P. Martinez-Estesó
Alejandro Galán-Cuenca
Antonio Javier Gallego

University Institute for Computing Research
University of Alicante, Spain
fcastellanos@dlsi.ua.es

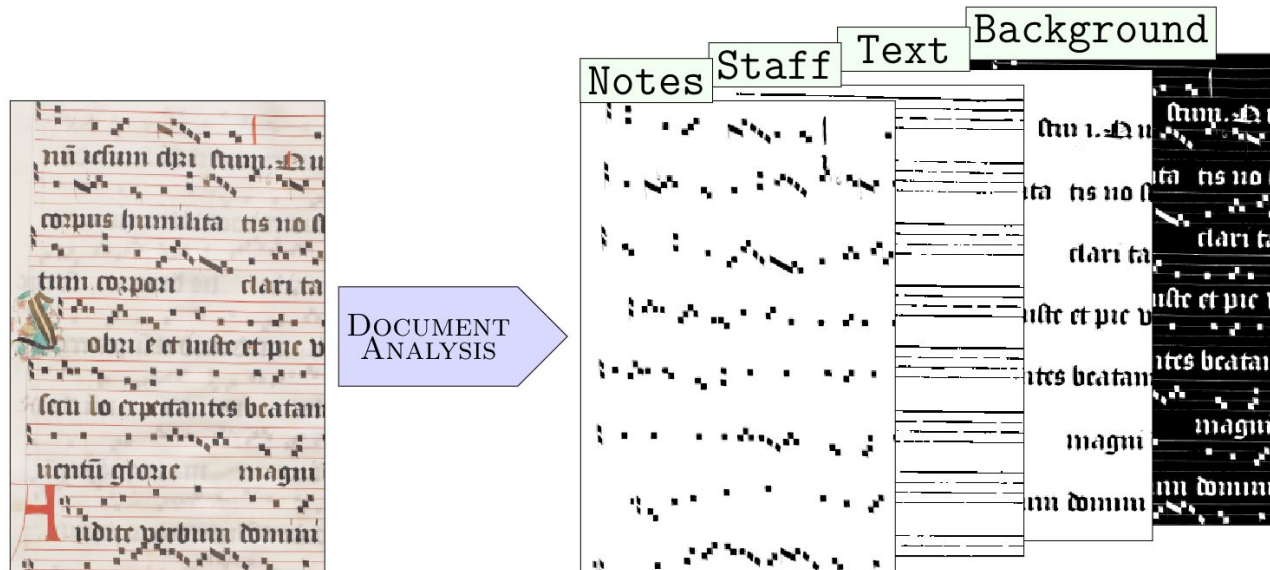


Funded by the
European Union
NextGenerationEU



Layout analysis

Introduction



Layout analysis

Motivation

EINSIEDELN (EIN)



10 pages of $5\,550 \times 3\,650$ px.

SALZINNES (SAL)



10 pages of $5\,100 \times 3\,200$ px.

How obtaining ground truth for training a model?



Annotating a lot of pages.



Annotating a few pages.



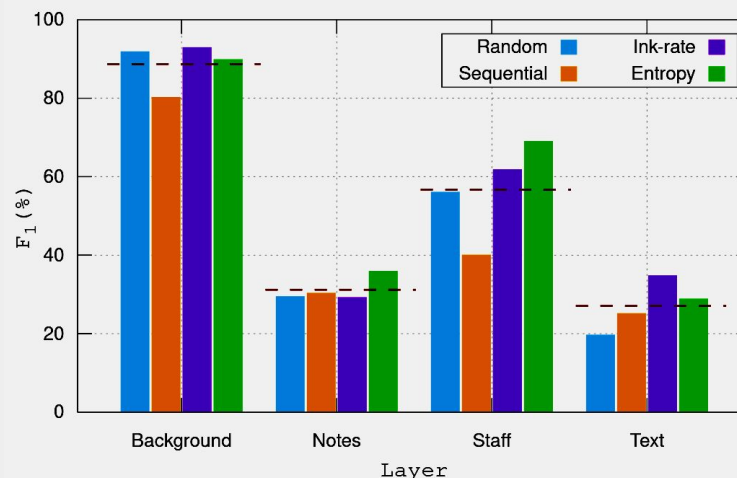
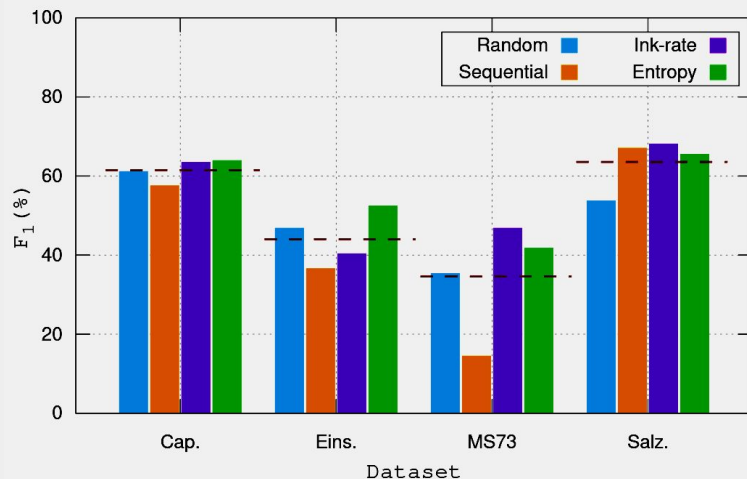
Annotating a few selected samples.

Methodology



- We divide the image in selectable patches.
- We annotate **one patch** for training.
- What patch should we select?
 - Entropy.
 - Amount of pixels for the layer of interest.
 - Randomly.
- This process would be iterative, until obtaining a robust model.

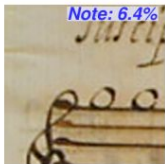
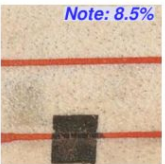
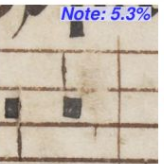
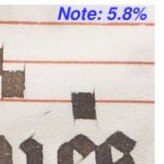
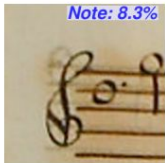
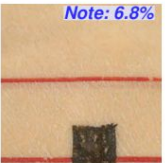
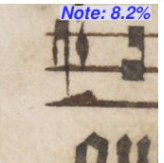

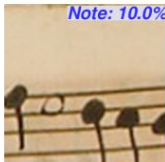
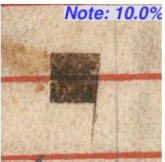
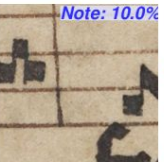
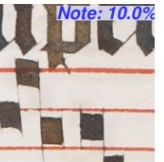

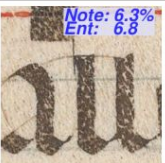
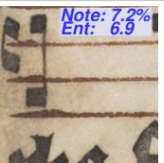
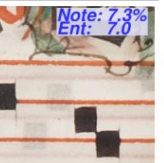
Experiments



Metric	Random	Sequential	Ink-rate	Entropy
F_1 (%)	49.2	43.9 ^{-5.3}	54.6 ^{+5.4}	55.9 ^{+6.7}

*Superscript values denote the improvement rate (%) with respect to the random method (baseline).

Conclusions

Criterion	CAPITAN	MS73	EINSIEDELN	SALZINNES
Random	 Note: 6.4%	 Note: 8.5%	 Note: 5.3%	 Note: 5.8%
Sequential	 Note: 8.3%	 Note: 6.8%	 Note: 8.2%	 Note: 6.7%
Ink-rate	 Note: 10.0%	 Note: 10.0%	 Note: 10.0%	 Note: 10.0%
Entropy	 Note: 10.0% Ent: 6.9	 Note: 6.3% Ent: 6.8	 Note: 7.2% Ent: 6.9	 Note: 7.3% Ent: 7.0

- Ink rate selection is not always the best option.
- The use of **entropy** seems to be adequate.
- We plan to extend the experiments with more complex approaches.



Thanks for your attention

Pattern Recognition and Artificial Intelligence Group

This work was supported by the Spanish Ministerio de Ciencia e Innovación through the I+D+i DOREMI project (**TED2021-132103A-I00**), funded by MCIN/AEI/10.13039/501100011033.



Funded by the
European Union
NextGenerationEU



GOBIERNO
DE ESPAÑA

MINISTERIO
DE CIENCIA, INNOVACIÓN
Y UNIVERSIDADES



Universitat d'Alacant
Universidad de Alicante

